

VLT - DSM

Large convex aspherical Thin Shell Manufacturing

LAM: E.Hugot, M.Ferrari, G.Lemaître, P.Montiel, P.Lanzoni

SESO: JF Carre, D.Fappani

I. VLT DSM

- *Replace the actual secondary of one UT*
- *Goal: Correct for atmospheric turbulence inside the telescope*
- *Directly deliver a corrected wavefront at telescope focus*

Technical characteristics:

- *1.1m diameter*
- *Convex hyperbolic*
- *1170 voice coil actuators*
- *2mm Thin Shell !!*



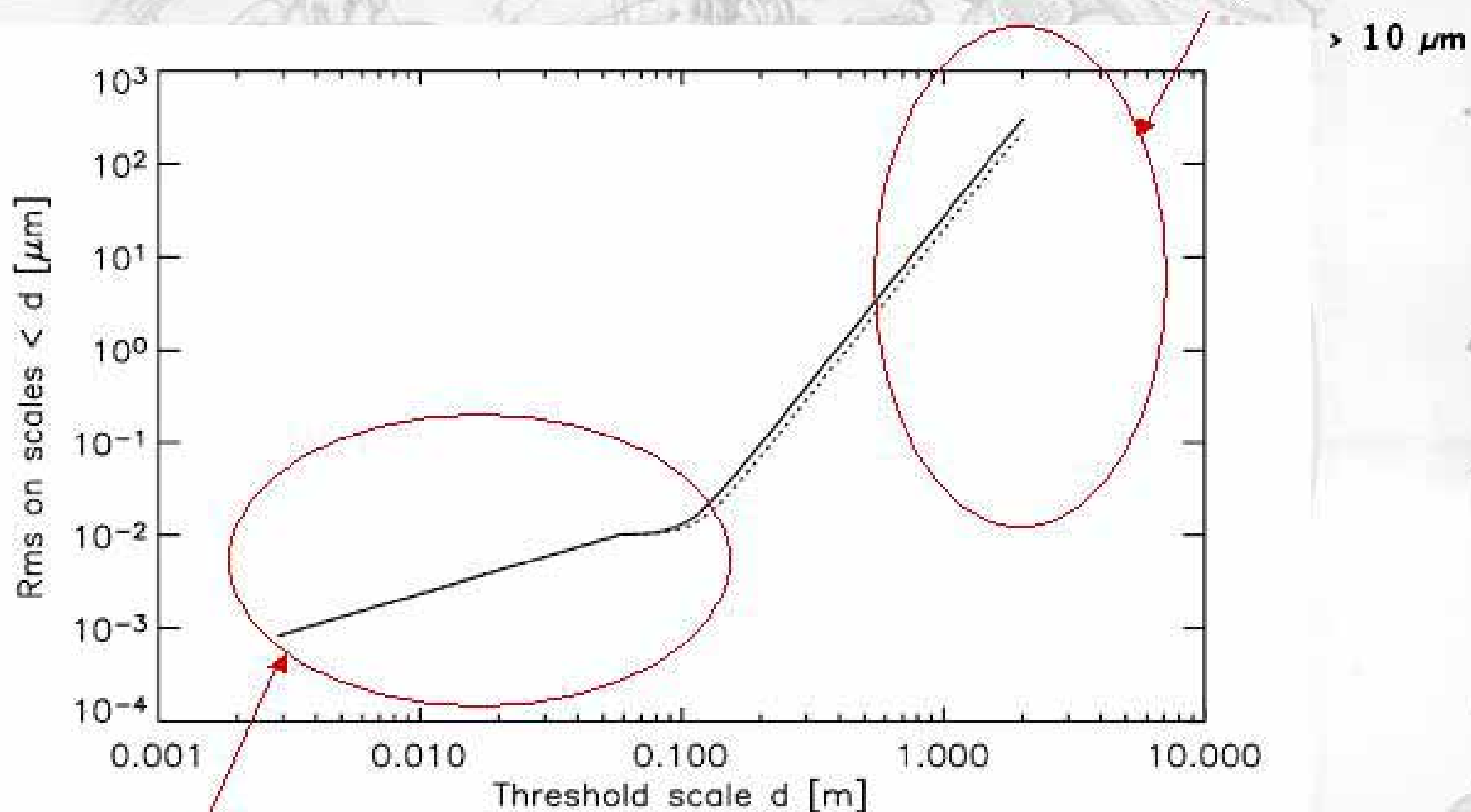
Optical quality specification

- 1- The shape of the mirror can be partially corrected by the 1170 actuators. (1/10 of their peak force).
→ relaxation in terms of low spatial frequency errors (large scales on the mirror).
- 2- However, below the Nyquist scale (twice the actuator pitch), the system cannot correct for surface errors
→ restrictions in terms of high spatial frequency errors (low scales on the mirror)
- 3- The correction of BFs generates HFs
→ restrictions on BFs respect to HFs

→ Envelope of acceptable manufacturing errors

Envelope of acceptable manufacturing errors

Relaxed on low frequencies



Severe on high frequencies

$< 10\text{nm}$

21-22 Novembre 2007

→ Active optics - Stress Polishing

JR10A - Arcachon

Active Optics

Goal:

Generating and controlling deformations on telescopes and instruments mirrors.

Gain:

Obtaining complex optical surfaces of excellent quality, statically and/or dynamically

Applications:

1. **Stress polishing**
2. Maintaining an optimal shape of a mirror
3. Variable surface mirrors

Stress Polishing Process

1 Plane-Convex Zerodur blank 



2 Deformation of the substrate under air back pressures



3 Spherical polishing with full size tool



4 Stress relaxation and final form



5 Clung on a spherical mould 



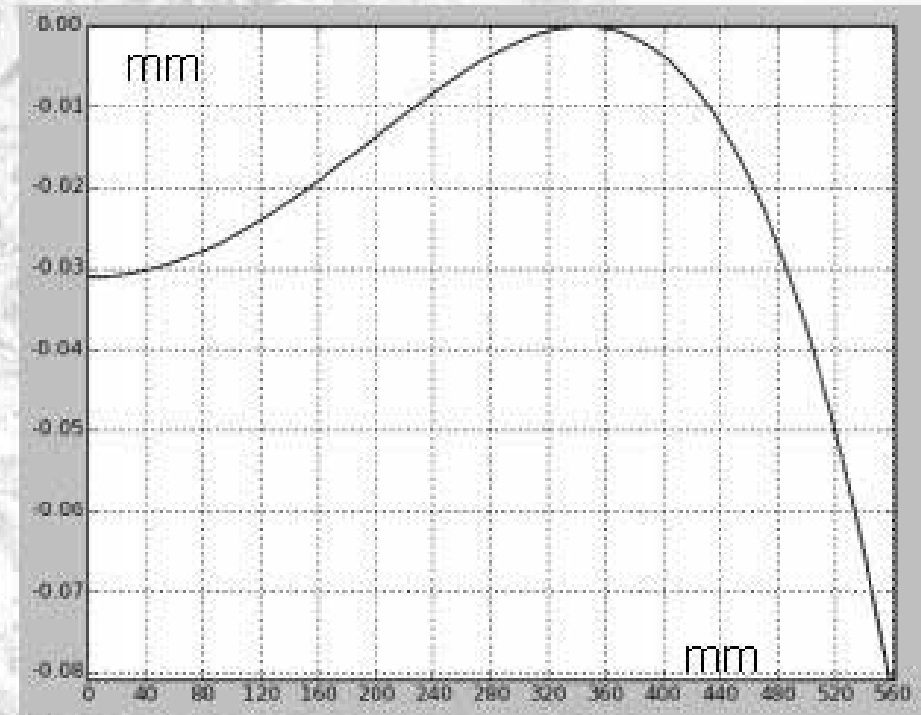
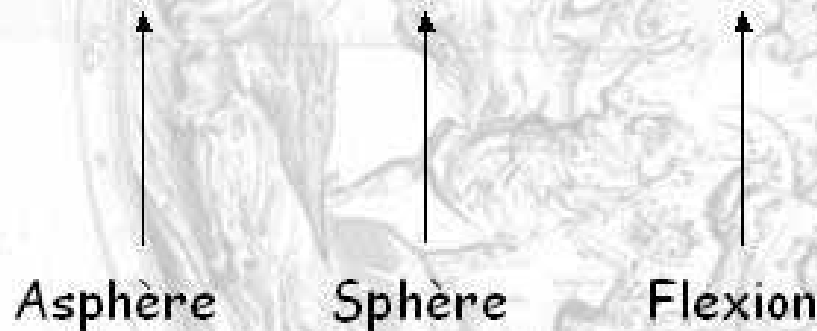
6 Back face spherical thinning 



Desired flexure

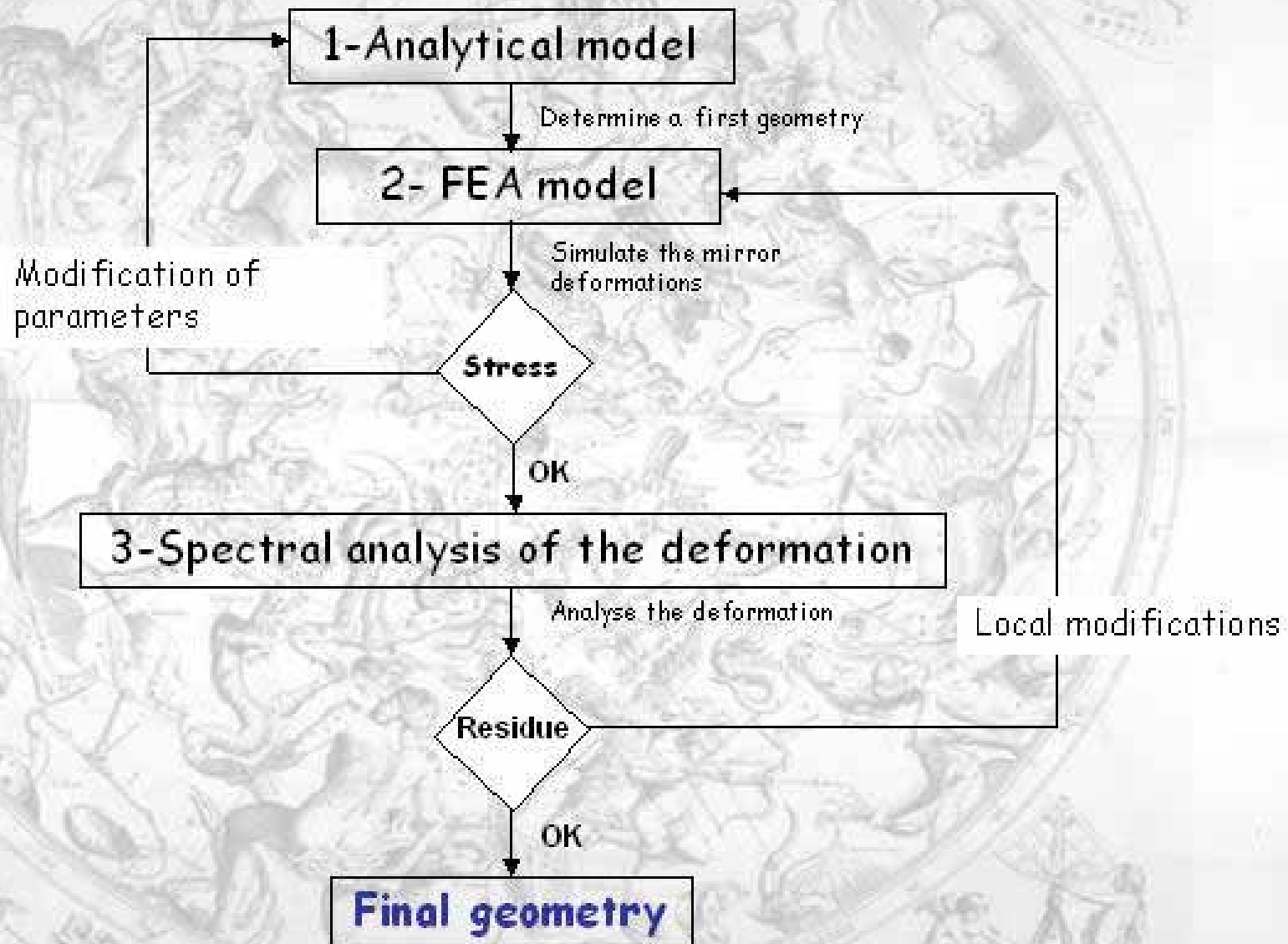
- Inverse of the final aspherical form

$$Z_a(r) = Z_s(r) - Z_{flex}(r)$$



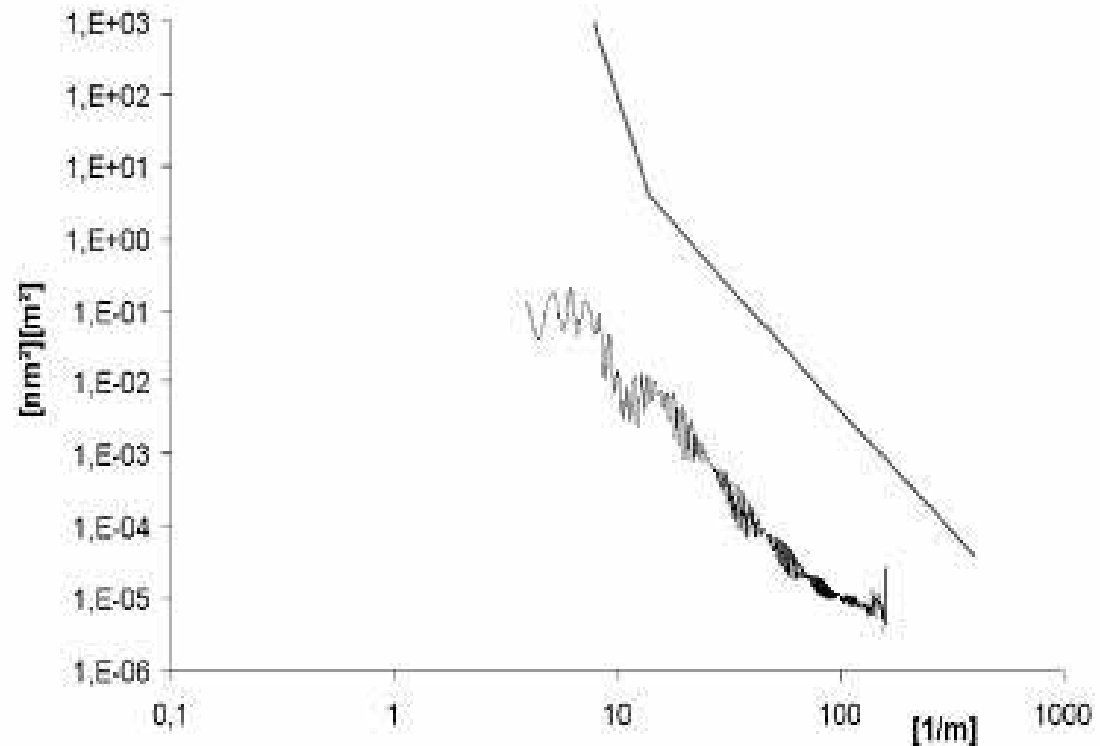
- Optical quality **linked** to the deformation function residuals → depends on the blank geometry

Definition of the blank geometry



Manufacturing residuals estimations

- Comparison of residuals with specifications
 - estimates the optical quality of mechanical deformations

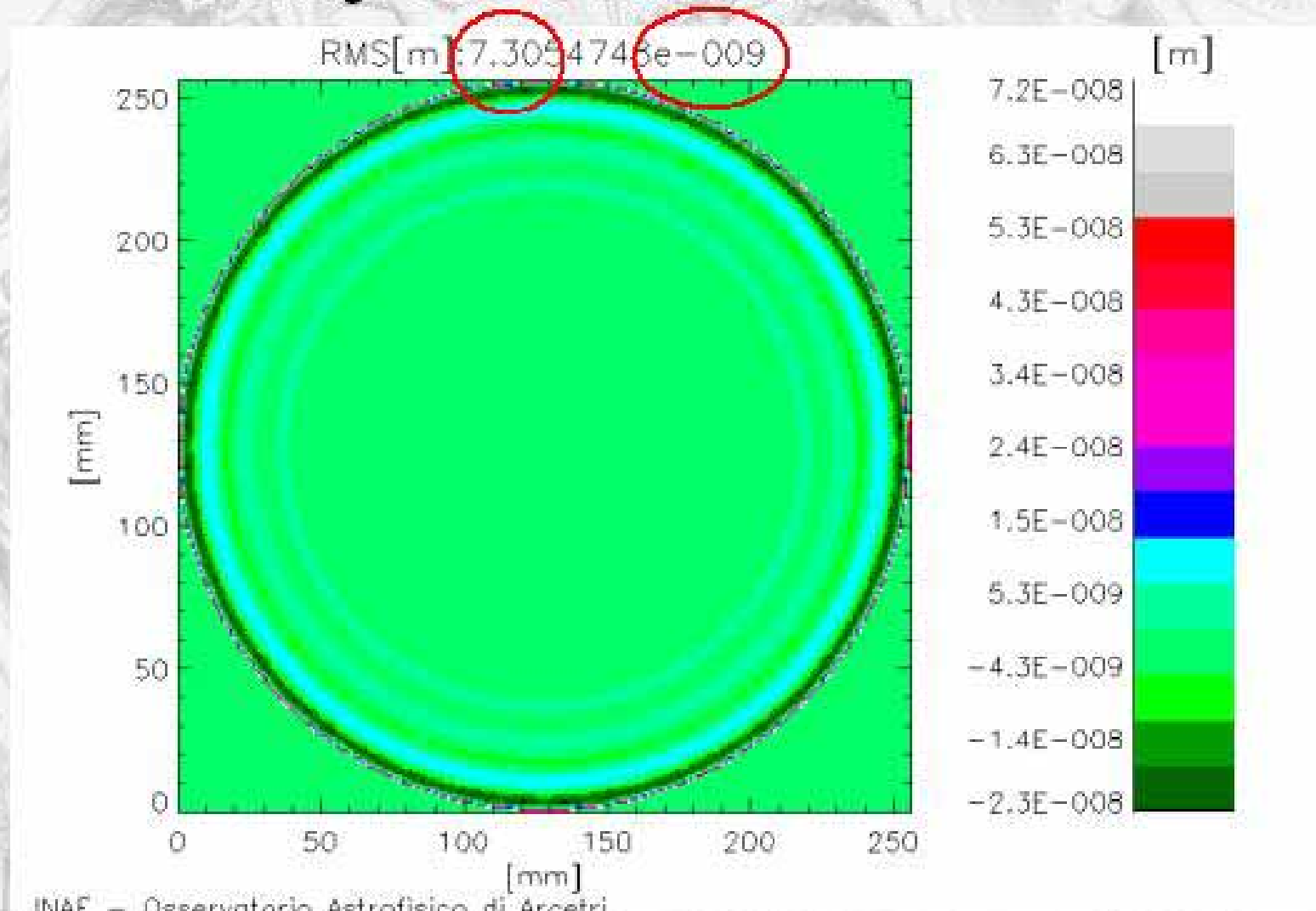


PSD of flexure residuals vs PSD spec

- Numerical validation of the manufacturing process

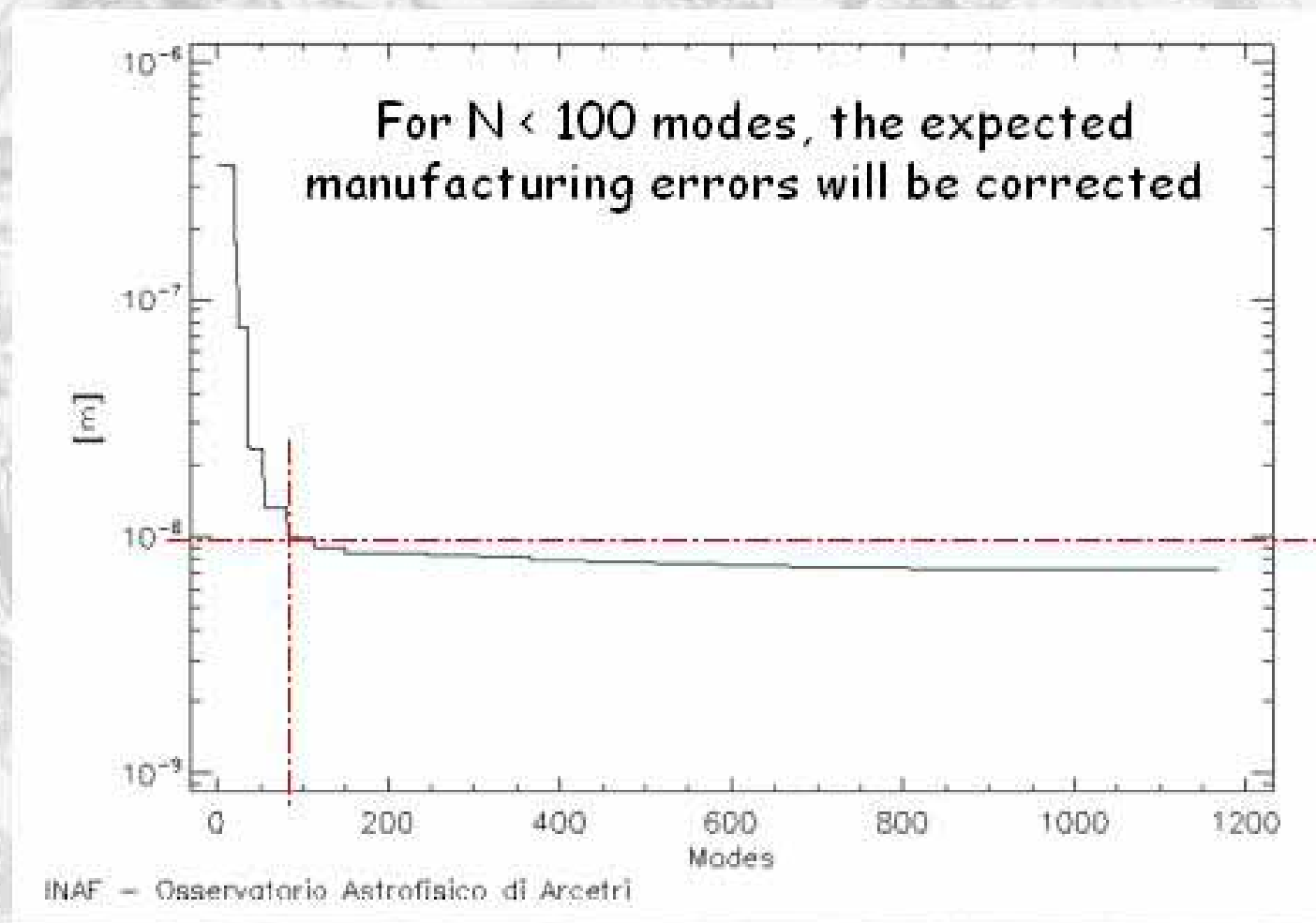
Manufacturing residuals estimations

Flattening residuals estimation < 8nm



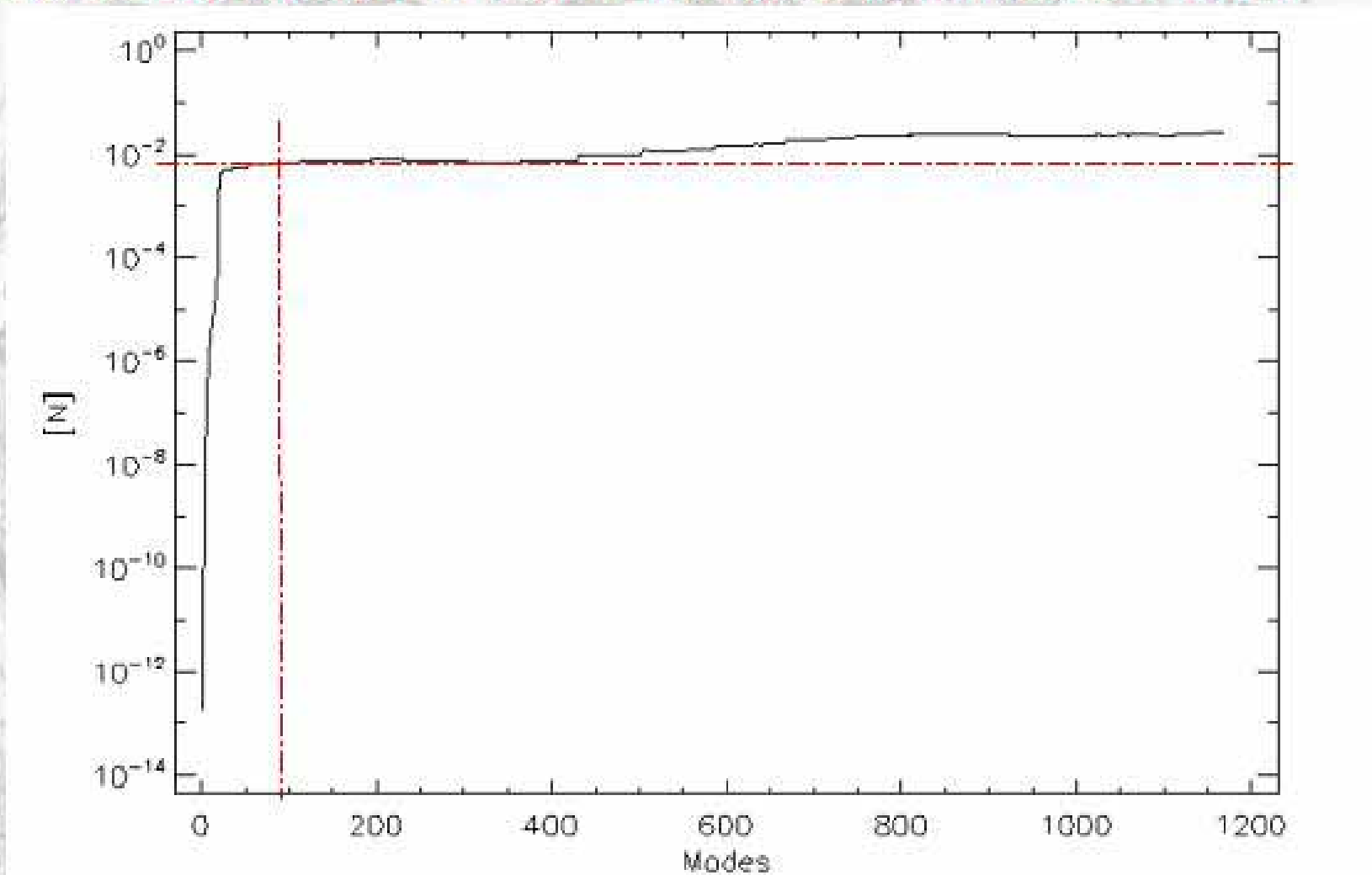
Manufacturing residuals estimations

Residue rms on surface vs N modes corrected



Manufacturing residuals estimations

RMS Force needed to flatten the shell vs N modes < 0.1N



Manufacturing Plan

I - Preparation and installation

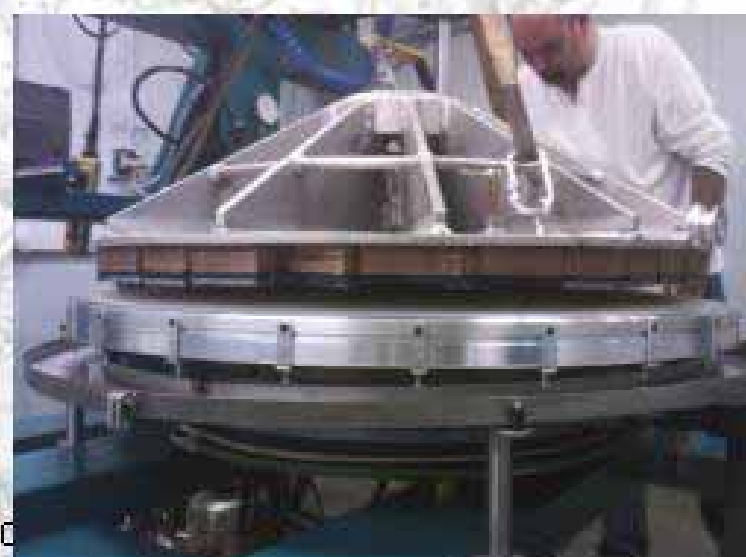
II - First spherical polishing under stress

III - Final aspherisation under stress

IV - Final thinning (@ SESO)

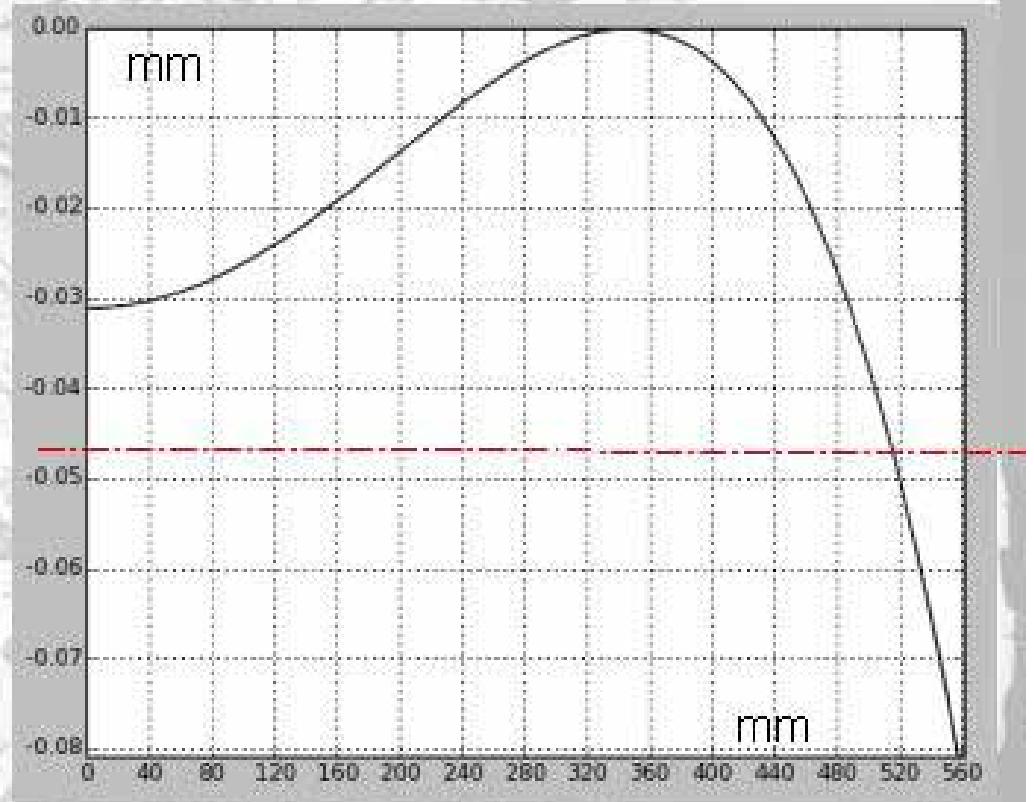
LAM Polishing Machine

- New 1.3m active polishing machine



LAM Polishing operations

Removed matter



First measurements

- Before interferometric tests, several mechanical measurements are done, regarding the **polishing ROC** and the **real "centre-to-edge" flexure** obtained.
 - Nominal "centre-to-edge" flexure obtained with a **slight re-adjustment** (<1%) of the theoretical pressure (-300.9 mb = safety pressure...)
 - Radius of curvature measured during grinding = **4580.3mm**
To be compared with best sphere specification = 4575mm +/-10mm

Good Departure 😊

VLT M2 Matrix

- Spectral qualification of the VLT M2 matrix (May-June 2007) on High spatial frequencies



Test Plan

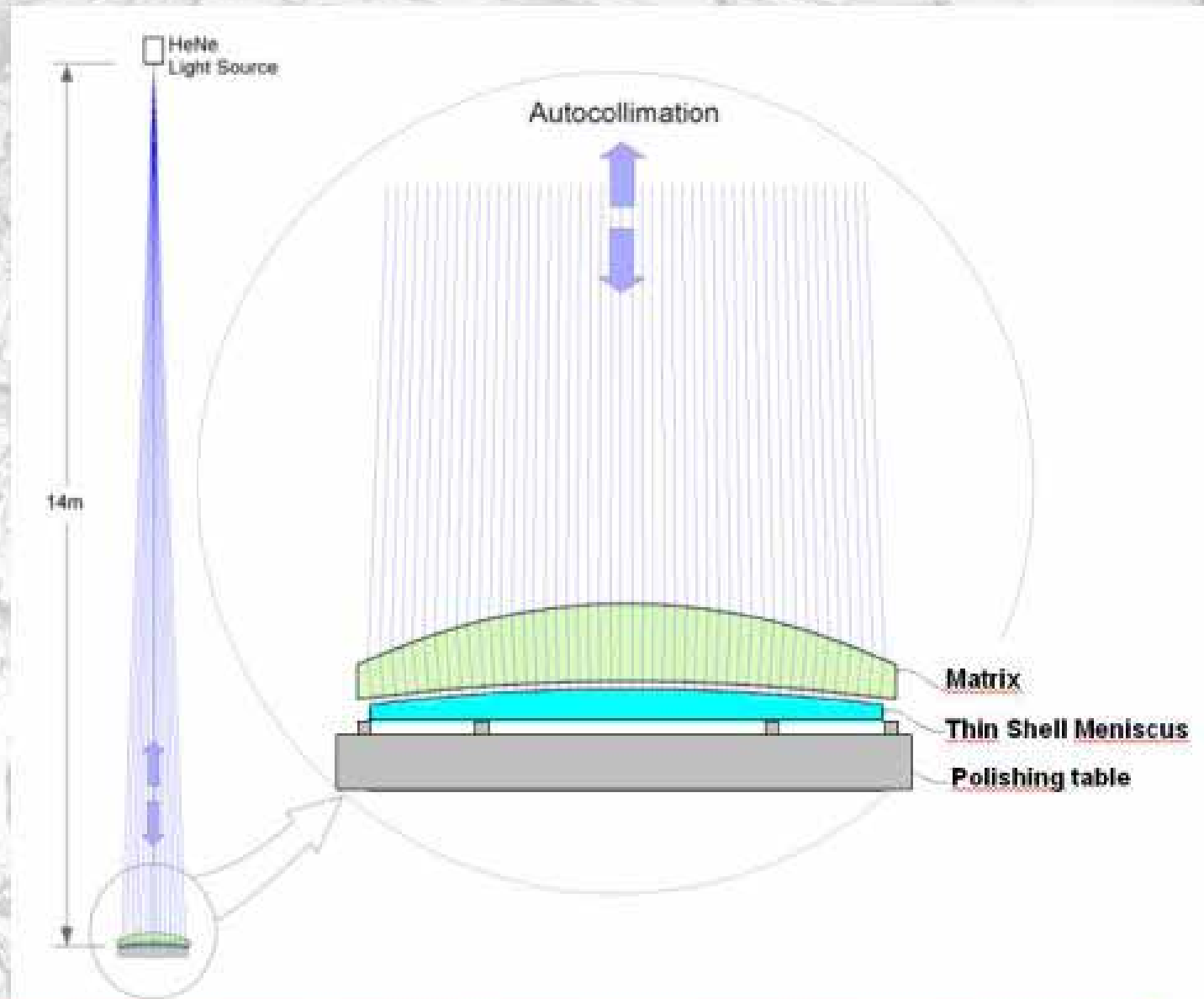
- Two set-up for LF/MF and High Spat. Freq. Errors
 - Low/Medium spatial frequencies errors → ESO Matrix
 - High spatial frequencies errors → Dedicated HQ 200 mm Ø Sphere
 - Low/Medium Spatial Freq. errors [1/1000 - 1/100] mm⁻¹
 - Control during active polishing (meniscus)
 - Control after final active polishing (meniscus)
 - Control after thinning to 2mm (shell)
 - High Spatial Freq. errors [1/200 - 1/10] mm⁻¹
 - Control after final active polishing (meniscus) on sphere

Test N°1

■ Low/Medium Spatial Freq. errors

Using ESO
VLT - M2 Matrix

Active system : OFF
Aspherical surface



Control during active polishing, after final active polishing (meniscus)
and after thinning to 2mm (shell)

Test N°2

- High Spatial Freq. errors

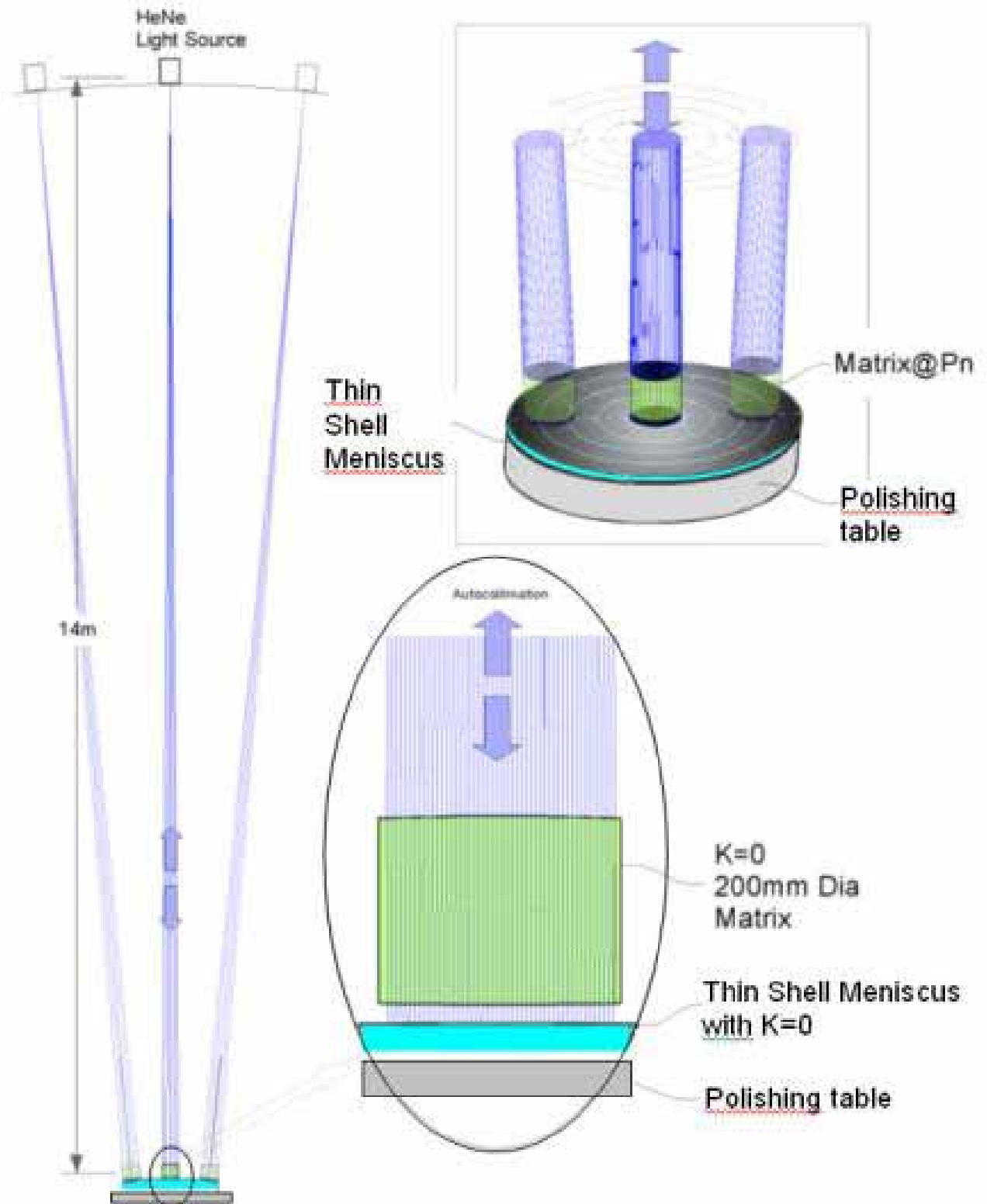
Using special high quality spherical matrix 200mm \varnothing

Active system : ON
Spherical surface

Control after final active polishing (meniscus)

No new control after thinning

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Polishing operations



Thanks!